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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: OHMOTO et al

Serial No.: 10/663,646

Filed: September 17, 2003

For: Plasma Processing Apparatus

Art Unit: 1763

Examiner: R. Dhingra

<u>AMENDMENT</u>

Mail Stop: Amendment (No Fee) Commissioner For Patents P.O. Box 1450 Alexandria, VA 22313-1450

missioner For Patents December 8, 2005

Sir:

The following amendments and remarks are respectfully submitted in connection with the above-identified application, in response to the Office Action dated September 8, 2005. The amendments are listed below and set forth on the following pages.

Amendments to the Specification;

Amendments to the Claims; and

Remarks are included following the amendments.